



Sheet 1 of 1

Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office				Atty. Docket No.: FMW-BL		Serial No.: 10/754,151	
LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				Applicant: Dr. Andrey E. Yakshin, et al.			
				Filing Date: 01/09/04		Group: 1709	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclas s	Filing date if appropriat e
	AA						
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	AL						
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OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
/MB/	AR		P. J. Martin "Ion-Based Methods for Optical Thin Film Deposition", Journal of Material Science 21 (1986) pp. 1-25 entitled,				
	AS						
EXAMINER		/Michael Band/		DATE CONSIDERED		04/18/2007	
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